## PATENT APPLICATION D cket No. 8750-03.8 Client No. SPX200212-0009US

Sung-Jin KIM, Seung-Hyun CHANG and Ki-Heum NAM Applicant: 123,688 10 not yet assigned H. Nu not yet assigned Examiner: Serial No. not yet assigned 281 October 14, 2003 Group: Filing Date: PHOTO MASK SET FOR FORMING MULTI-LAYERED INTERCONNECTION LINES For: AND SEMICONDUCTOR DEVICE FABRICATED USING THE SAME INFORMATION DISCLOSURE CITATION FORM PTO-1449 (Modified) **U.S. PATENT DOCUMENTS** Sub Document Issue Exam Class Name Class <u>Init</u> <u>Ref</u> Number <u>Date</u> 5 430 Chen et al. 5,242,770 9/7/1993 FOREIGN PATENT DOCUMENTS **Publication** Document Exam Number Country Name Date <u>Init</u> Ref **OTHER DOCUMENTS** Exam Author, Title, Date, Pertinent Pages, Etc.) Init Ref

Examiner: H. Vu

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